

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q81941

Kenji ITO, et al.

Appln. No.: 10/500,253

Group Art Unit: 1725

Confirmation No.: 8926

Examiner: Maria A. ELVE

Filed: June 25, 2004

For: LASER MATERIAL PROCESSING METHOD

**RESPONSE UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 23, 2006, please consider the Remarks set forth on the accompanying pages.